



# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D.C. 20231 on July 26, 2000.*

*[Signature]*  
R.L. Milton

Applicant : Francis M. Reininger  
 Application No. : 09/547,790  
 Filed : April 12, 2000  
 Title : SPATIALLY MODULATED INTERFEROMETER AND BEAM  
 SHEARING DEVICE THEREFOR

Grp./Div. : 2877  
 Examiner : n/a

Docket No. : 39260/RAG/C766

## PRELIMINARY AMENDMENT

Assistant Commissioner for Patents  
 Washington, D.C. 20231

Post Office Box 7068  
 Pasadena, CA 91109-7068  
 July 26, 2000

Commissioner:

Entry of the following amendments prior to examination of the referenced application is respectfully requested:

### IN THE SPECIFICATION:

At page 17, line 6, delete the colon (":") and insert a period ("."); and,

At page 17, delete lines 7-12.

RECEIVED  
 AUG 7 2000  
 COMMUNITY CENTER 2800